

Table of Contents

Diffusion in Collision Cascades: a Thermodynamic Viewpoint	1
M. Van Rossum and Y.T. Cheng	
Simulations of Damage Induced by Ion Bombardment: A Review	33
A.M. Mazzone	
The Production of Periodic Surface Features by Sputtering and Related Processes	49
G. Carter, I.V. Katardjiev and M.J. Nobes	
Distributions of Implanted Ions in Solids	61
M. Hautala and I. Koponen	
The Application of TEM and THDS to the Study of Helium-Vacancy Cluster Growth and Helium-Dislocation Interactions in Metals	75
W.T.M. Buters, J.H. Evans, A. van Veen and A. van den Beukel	
The Role of Bombardment Induced Defects in the Initiation of Topography on Ion Bombarded F.C.C. Metals	97
G. Carter, M.J. Nobes, I.V. Katardjiev and J.L. Whitton	
Microstructure Control in Surface Modified Materials Using Prototype Systems	127
R.B. Benson, Jr.	
Microstructures in Ion Implanted Titanium	135
R.G. Vardiman	
Amorphisation of Metals by Ion Implantation and Ion Beam Mixing	143
B. Rauschenbach and V. Heera	
Thermal Oxidation of Ion-Implanted Metals	189
M. Pons, A. Galerie and M. Caillet	
Helium Bubbles in Metals Studied by Positron Techniques	207
K.O. Jensen	
Thermal Spike Regime during Ion Implantation: New Aspects	221
L.M. Gratton, A. Miotello and C. Tosello	
Ion-Implantation Induced Phase Transitions as Studied by Mössbauer Spectroscopy	229
J.P. Eymery and A. Fnidi	
Ion Implantation Induced Martensitic Transformations in Metals	241
E. Johnson	
Composite Surface Layer Formation Produced by Low Energy Cs⁺ Bombardment on: Be, Mo, & W	263
G.S. Tompa, M. Seidl and W.E. Carr	
Nitrogen Implantation in Iron and Steels	273
G. Marest	
Ion Implantation in Stainless Steels: Microstructures and Mechanical Properties	327
S. Fayeulle	
The Mechanical Properties of Ion Implanted Ceramics - A Review	359
C.J. McHargue	
Modification of the Refractory Metal Silicides Surface Induced by Low Energy Ion Bombardment	381
S. Valeri	
Highly Energetic Heavy Ion Irradiation Effects in Ferrites	391
D. Groult, M. Hervieu, N. Nguyen, F. Studer and M. Toulemonde	
Defect Production in Alkali Halide Crystals by Ion Implantation	409
J.D. Comins, A.T. Davidson and T.E. Derry	
Radiation Damage in Nb/Nb Oxide/PbAuIn Josephson Tunnel Junctions due to Ion Implantation	425
S.I. Raider and G.J. Clark	
Ion Implantation in Oxides on Silicon	431
A. Vengurlekar	
Defects and Doping Effects in CdTe and CuInS₂ by Phosphorus Ion Implantation and Pulsed Electron Beam Annealing	445
H.Y. Ueng and H.L. Hwang	